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Attorney's Docket No.: 042390P6958

Patent

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of: )

Anne E. Miller et al. )

U.S. Serial No: 09/461,158 )

Examiner: Brown, C. A.

Filed: December 14, 1999 )

Art Unit: 1765

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TC 1700

Assistant Commissioner for Patents  
and Trademarks  
Washington, D.C. 20231

**AMENDMENT AND RESPONSE**

Dear Sir:

This is in response to the Office Action mailed August 14, 2002. Applicant respectfully requests the Examiner to enter the following amendments and consider the following remarks.

**FIRST CLASS CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Assistant Commissioner of Patents, Washington, D.C. 20231

on Monday, December 16, 2002  
Date of Deposit

Teresa Edwards

Name of Person Mailing Correspondence

Teresa Edwards  
Signature

December 14, 2002  
Date

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